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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/807,029	03/23/2004	Tze-Chiang Chen	FIS920010295US3	2255
7590	09/16/2004		EXAMINER	
Margaret A. Pepper International Business Machines Corporation 2070 Route 52 Hopewell Junction, NY 12533				LEE, CALVIN
				ART UNIT PAPER NUMBER
				2825

DATE MAILED: 09/16/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary	Application No.	Applicant(s)	
	10/807,029	CHEN et al.	
	Examiner	Art Unit	
	Lee, Calvin	2825	

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address --

Period for Reply

A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.

- Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.
- If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.
- If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.
- Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).

Status

1) Responsive to communication(s) filed on ____.

2a) This action is FINAL. 2b) This action is non-final.

3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under *Ex parte Quayle*, 1935 C.D. 11, 453 O.G. 213.

Disposition of Claims

4) Claim(s) 1,2 and 4-19 is/are pending in the application.
4a) Of the above claim(s) _____ is/are withdrawn from consideration.

5) Claim(s) _____ is/are allowed.

6) Claim(s) 1,4-14,17 and 18 is/are rejected.

7) Claim(s) 2,15,16 and 19 is/are objected to.

8) Claim(s) _____ are subject to restriction and/or election requirement.

Application Papers

9) The specification is objected to by the Examiner.

10) The drawing(s) filed on _____ is/are: a) accepted or b) objected to by the Examiner.

Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).

Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).

11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.

Priority under 35 U.S.C. § 119

12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
a) All b) Some * c) None of:
1. Certified copies of the priority documents have been received.
2. Certified copies of the priority documents have been received in Application No. _____.
3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).

* See the attached detailed Office action for a list of the certified copies not received.

Attachment(s)

1) Notice of References Cited (PTO-892)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948)
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08)
Paper No(s)/Mail Date 2.

4) Interview Summary (PTO-413)
Paper No(s)/Mail Date. ____ .

5) Notice of Informal Patent Application (PTO-152)

6) Other: ____ .

OFFICE ACTION

Claim Objection

1. Claim 14 is objected to because of the following informality:

Claim 14, line 2, replace “conductive material” with --conductor--

Claim Rejections - 35 U.S.C. § 102

2. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Note: This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

3. Claims 1, 4, 8, 10, 14, and 17-18 are rejected under 35 U.S.C. 102(e) as being anticipated by *Wang (US 20020100907)*.

a) *Wang* discloses an interconnect structure formed on a substrate, comprising:

- a hardmask layer 26 of SiN, which has a top surface [Fig. 1], on a dielectric layer 18
- a conductive liner/barrier 20 in openings [Fig. 3] within the dielectric layer
- at least one conductor 22, 24 embedded in the dielectric layer, which has a surface coplanar with the top surface of the hardmask layer 26
- a first cap layer 28 of SiN on the conductor and on the hardmask layer [pages 1-2]
- a second cap layer 38 (of SiN, SiC, or other etch stop material) on the first cap layer, wherein

b) In re claims 17-18, *Wang* also suggests the first and second cap layers have a thickness of from about 10nm to about 200nm (equivalent to 100-2000Å).

Claim Rejections - 35 U.S.C. § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negated by the manner in which the invention was made.

5. Claim 5 is rejected under 35 U.S.C. 103(a) as being anticipated by *Wang*, as applied to claim 1, in view of *APA* (*Applicant's Prior Art*).

Wang is silent about an adhesion promoter layer. Nevertheless, such adhesion promoter layer is known to the semiconductor processing art as evidenced by *APA* disclosing at least an adhesion promoter **11** on a substrate **10** [Fig. 1].

It would have been obvious to one of ordinary skill to have modified the process of *Wang* by utilizing an adhesion layer for the purpose of promoting an adhesion between the substrate and the overlying interconnect structure.

6. Claims 6 and 7 are rejected under 35 U.S.C. 103(a) as being anticipated by *Wang*, as applied to claim 1, in view of *Applicant's Prior Art*, and further in view of *Ngo et al* (US 6,528,432).

Wang does not disclose that the dielectric layer is formed of an organic thermoset polymer having a dielectric constant of about 1.8 to about 3.5. *APA* [page 3] discloses dielectric layers **12** and **19** made of a low-k polymeric thermoset material. Moreover, *Ngo et al* also suggests other low-k (≈ 3) dielectrics including various poly(arylene)ethers, etc [col. 4].

It would have been obvious to one of ordinary skill to have modified the dielectric layer of *Wang* by utilizing a polymer dielectric layer (whose dielectric constant is much lower) for advanced interconnect structure with a lower capacitance.

7. Claims 9 and 11-13 are rejected under 35 U.S.C. 103(a) as being anticipated by *Wang*, as applied to claim 1, in view of *Ngo et al* (US 6,593,237).

Wang is silent about the composition of the first and second cap layers. *Ngo et al* '237 suggests a stop layer of SiN with a hydrogen concentration above atomic %" [col. 4]. However, *Ngo et al* does not explicitly disclose the claimed amount of silicon, nitrogen (or carbide), and hydrogen in the composition of the cap layers.

It would have been an obvious to one having ordinary skill in the art to have modified the cap layers of *Wang* by utilizing the claimed composition because one would adjust either the concentration ratio or the atomic amount of depositing materials (i.e., silicon, nitrogen, and hydrogen) to result in the most effective cap layers.

Allowable Subject Matter

8. Claims 2, 15-16, and 19 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims. None of the cited arts suggests the first cap layer formed by HDP CVD and the second cap layer formed by PE CVD, wherein the second cap layer comprises a plurality of thin films.

Contact Information

9. Any inquiry concerning this communication from the Examiner should be directed to *Calvin Lee* at (571) 272-1896, Monday to Thursday, from 7 to 5 (ET). If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2825's Supervisory Patent Examiner *Matthew Smith* whose telephone number is (571) 272-1907.

Any inquiry relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 308-0596. The fax phones are (703) 872-9318 for regular communications and (703) 872-9319 for After-Final communications.

calvin lee

September 10, 2004